

Notice of References Cited

Application/Control No.

10/020,543

Applicant(s)/Patent Under
Reexamination
MI ET AL.

Examiner

Mike Qi

Art Unit

2871

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,034,756 ✓	03-2000	Yuan et al	349/119
	B	US-5,747,121 ✓	05-1998	Okazaki et al	428/1
	C	US-6,319,963 ✓	11-2001	Coates et al	522/1
	D	US-5,796,456 ✓	08-1998	Takatori et al	349/117
	E	US-6,081,312 ✓	06-2000	Aminaka et al	349/118
	F	US-5,504,603 ✓	04-1996	Winker et al	359/73
	G	US-5,793,455 ✓	08-1998	Nakamura	349/96
	H	US-5,940,155 ✓	08-1999	Yang et al	349/120
	I	US-6,261,649 ✓	07-2001	Takagi et al	428/1
*	J	US-6,141,075 ✓	10-2000	Ohmuto et al	349/130
	K	US-6,115,095 ✓	09-2000	Suzuki et al	349/141
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	J Chen et al; "Optimum Film Compensation Modes for TN and VA LCds"; SID 1998, pp.315-318
*	V	K. Ohmuro et al; "Development of Super-High-image-Quality Vertical-Alignment-Mode LCD"; SID 1997, pp. 845-848
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.